

Lesker U

Vacuum Technology Workshop



Sponsored by:

Materials Research Lab
Micro & Nanotechnology Lab

March 27 & 28, 2018

Room 190
Engineering Sciences Building

Course Schedule

Tuesday, March 27

Introduction to vacuum science & system design

Vacuum pumps for high & ultra-high vacuum applications

Vacuum gauging

Seals, flanges and valves

Wednesday, March 28

Physical deposition & thin film growth models

Introduction to atomic layer deposition

There is no cost to attend, but registration is required:

mrl.illinois.edu/lesker-workshop-2018